

Form PTO-1449

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LIST OF ART CITED BY APPLICANT

(Use several sheets if necessary)

Attorney Docket No.
CE08387R

Serial No.

Filing Date
3/08/2001Applicant:
CHEN ET AL.

Group

U.S. PATENT DOCUMENTS

Examiner's Initial		Document No.	Date	Name	Class	Subclass	
ml	AA	5,999,815	12/7/99	TenBrook et al.	455	436	
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						

FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Class	Subclass	Translation
	AI						
	AJ						
	AK						

OTHER PRIOR ART (Including Author Title, Date, Pertinent Pages, Etc.)

	AL	
	AM	
	AN	

EXAMINER

m. Brubaker

DATE CONSIDERED:

11-5-04

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11046 U.S. PTO
09/801891
03/08/01

Form PTO-1449	LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use Several Sheets if Necessary)	ATTY. DOCK NO.	SERIAL NO.
		JG00048	TBA
		FILING DATE	GROUP
		3/8/01	TBA 2637

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	ISSUE DATE	NAME	CLASS	SUBCLASS	FILING DATE
AM	A	4 5 2 3 2 1 1	6/11/85	Morimoto et al.	357	4	3/8/83
	B	5 4 7 8 6 5 3	12/26/96	Guenzer	428	446	4/4/94
	AA	3 8 0 2 9 6 7	4/9/74	Landany et al.	148	171	8/27/91
	AB	4 4 0 4 2 6 5	9/13/83	Manasevit	428	689	4/7/78
	AC	4 4 8 2 9 0 6	11/13/84	Hovel et al.	357	16	6/30/82
	AD	4 8 4 6 9 2 6	7/11/89	Kay et al.	156	612	9/3/87
	AE	4 8 8 2 3 0 0	11/21/89	Inoue et al.	437	236	10/6/88
	AF	4 8 9 1 0 9 1	1/2/90	Shastri	156	606	6/8/87
	AG	4 9 2 8 1 5 4	5/22/90	Umeno et al.	357	16	3/20/89
	AH	4 9 6 3 9 4 9	10/16/90	Wanlass et al.	357	16	9/30/88
	AI	4 9 9 9 8 4 2	3/12/91	Huang et al.	372	45	3/1/89
	AJ	5 1 4 1 8 9 4	8/25/92	Bisaro et al.	437	132	7/20/90
	AK	5 1 5 5 6 5 8	10/13/92	Inam et al.	361	321	3/5/92
	AL	5 1 5 9 4 1 3	10/27/92	Calviello et al.	505	1	12/11/90
	AM	5 2 2 1 3 6 7	6/22/93	Chisholm et al.	148	33	8/3/88
	AN	5 2 2 5 0 3 1	7/6/93	McKee et al.	156	612	4/10/91
	AO	5 2 4 8 5 6 4	9/28/93	Ramesh	428	688	12/9/92
	AP	5 2 7 0 2 9 8	12/14/93	Ramesh	505	1	8/4/92
	AQ	5 3 1 0 7 0 7	5/10/94	Oishi et al.	501	126	9/28/92
	AR	5 3 2 6 7 2 1	7/5/94	Summerfelt	437	131	5/1/92
	AS	5 4 1 8 3 8 9	5/23/95	Watanabe	257	295	11/9/93
	AT	5 5 5 6 4 6 3	9/17/96	Guenzer	117	90	6/5/95
	AU	5 6 7 0 7 9 8	9/23/97	Schetzina	257	96	3/29/95
	AV	5 6 7 4 3 6 6	10/7/97	Hayashi et al.	204	298.09	6/7/95
	AW	5 7 3 1 2 2 0	3/24/98	Tsu et al.	437	60	6/7/95
	AX	5 7 3 5 9 4 9	4/7/98	Mantl et al.	117	8	4/7/98
	AY	5 7 4 1 7 2 4	4/21/98	Ramdani et al.	437	128	12/27/96
	AZ	5 8 0 1 1 0 5	9/1/98	Yano et al.	438	785	6/14/96
	BA	5 8 1 0 9 2 3	9/22/98	Yano et al.	117	84	5/10/96
	BB	5 8 2 8 0 8 0	10/27/98	Yano et al.	257	43	8/17/95
	BC	5 8 7 4 8 6 0	2/23/99	Brunel et al.	330	285	12/4/96
	BD	6 0 0 2 3 7 5	12/14/99	Corman et al.	343	853	9/2/97
	BE	6 0 4 5 6 2 6	4/4/00	Yano et al.	148	33.4	6/23/98
	BF	6 0 5 5 1 7 9	4/25/00	Koganei et al.	365	158	5/17/99
	BG	6 0 6 4 0 7 8	5/16/00	Northrup et al.	257	96	5/22/98
	BH	6 1 0 3 0 0 8	8/15/00	McKee et al.	117	2	7/30/98
	BI	6 1 0 7 6 5 3	8/22/00	Fitzgerald	257	191	6/23/98
	BJ	6 1 1 3 6 9 0	9/5/00	Yu et al.	117	84	6/8/98
AM	BK	6 1 4 3 0 7 2	11/7/00	McKee et al.	117	08	4/6/99

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FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	GRANT DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION YES NO
	BL 0250171	11/11/92	EPC			X
	BM 0342937	11/23/89	EPC			X
	BN 0455526	6/11/91	EPC			X
	BO 0602568	6/22/94	EPC			X
	BP 0607435	7/27/94	EPC			X
	BQ 1001468	5/17/00	EPC			X
	BR 0514018	11/19/92	EPC			X
	BT 0999600	5/10/00	EPC			X
	BU 1319311	6/6/73	Great Britain			X
	BV 6291299	10/18/94	Japan			X
	BW 1123868	8/31/99	Japan			X
	BX 1126083	9/24/99	Japan			X
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	BZ 5048072	2/26/93	Japan			X
	CA 5208835	7/23/77	Japan			X
	CB 5413455	10/19/79	Japan			X
	CC 5508742	7/2/80	Japan			X
	CD 6110818	5/26/86	Japan			X
	CE 6232126	8/19/94	Japan			X
	CF 6291299	10/18/94	Japan			X
	CG 6303499	2/15/88	Japan			X
	CI 6313110	6/3/88	Japan			X
	CH 6319836	8/17/88	Japan			X
	CJ 6327862	1/5/90	Japan			X
	CK 6334168	6/14/93	Japan			X
	CK 9914804	3/25/99	PCT			X
	CL 9963580	12/9/99	PCT			X

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Mr. Smith

11/8-04

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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

DA	DB	"Oriented Growth of SrTiO ₃ Films on Si(100) Substrates Using in situ Cleaning by Excited Hydrogen," H. Ishiware et al., Mat. Res. Soc. Symp., vol. 116, 1988., pp. 369-374
	DC	"A Preliminary Consideration of the Growth Behavior of CeO ₂ , SrTiO ₃ and SrVO ₃ Films on Si Substrate," Nagata et al., Thin Solid Films, 224, 1993, pp. 1-3.
	DD	"Heteroepitaxial Growth of CeO ₂ (001) Films on Si(001) Substrates by Pulsed Laser Deposition in Ultrahigh Vacuum," Nagata et al., Jpn. J. Appl. Phys., vol. 30, no. 6b, 1991, pp. 1136-1138.
	DE	"Heteroepitaxial Growth of SrO Films on Si Substrates," Kado et al., J. Appl. Phys., 61(6), 1987, pp. 2398-2400.
	DF	"Epitaxial Growth of Perovskite Type Oxide Films on Si Substrates," H. Ishiware et al., Mat. Res. Soc. Symp., vol. 220, 1991, pp. 595-600.
	DG	"Effects of Buffer Layers in Epitaxial Growth of SrTiO ₃ Thin Film on Si(100)," Nakagawara et al., J. Appl. Phys. 78(12), 1995, pp.7226-7230.
MA	DH	"A Proposal of Epitaxial Oxide Thin Film Structures for Future Oxide Electronics," Suzuki et al., Materials Science and Engineering B41 (1996), pp. 166-173.

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Mr. Condes

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ay	DX	"Impact of GaAs Buffer Thickness on electronic Quality of GaAs Grown on Graded Ge/GeSi/Si Substrates," Carlin et al., Appl. Phys. Letter, vol. 76, no. 14, April 2000, pp. 1884-1886.
	DY	"Epitaxial Integration of III-V Materials and Devices with Si Using Graded GeSi Buffers," Ringel et al., 27 th International Symposium on Compound Semiconductors, Oct. 2000.
	DZ	"Progress in Compound-Semiconductor-on-Silicon-Heteroepitaxy with Fluoride Buffer Layers," Zogg et al., J. Electrochem Soc., vol. 136, no. 3, March 1989, pp. 775-779.
	EA	"Oxide Defined GaAs Vertical-Cavity Surface-Emitting Lasers on Si Substrates," Xiong et al., IEEE Photonics Tech Letters, vol. 12, no. 2, Feb 2000, pp. 110-112.
	EB	"Investigation of PZT/LSCO/Pt/Aerogel Thin Film Composites for Uncooled Pyroelectric IR Detectors," Clem et al., Mat. Res. Soc. Symp. Vol. 541, pg. 661-666.
	EC	"Bound-To-Quasi-Bound Quantum-Well Infrared Photodetectors," Gunapala et al., NASA Tech Brief, vol. 22, no. 9.
	ED	"Monolithic InGaAs-on-silicon Short Wave Infrared Detector Arrays," Joshi et al., Int'l. Society for Optical Engineering, vol. 2999, pp. 211-224.
	EE	"Nanostructure and Chemistry of a (100)Mg/(100)GaAs Interface," Bruley et al., Appl. Phys Lett. 65(5), Aug. 1994, pp.564-566.
	EF	"Epitaxial MgO on Si(001) for Y-Ba-Cu-O Thin Film Growth by Pulsed Laser Deposition," Fork et al., Appl. Phys Lett 58(20), May 1991, pp. 2294-2296.
	EG	"Dielectrics on Semiconductors," Himpsel et al., Materials Science and Engineering, B1(1988), pp. 9-13.
✓	EH	"Epitaxial La 0.67 Sr 0.33 MnO ₃ Magnetic Tunnel Junctions," J. Appl. Phys. 81(8), Apr. 1997 pp. 5509-5511
pu	EI	"Colossal Magnetoresistance Magnetic Tunnel Junctions Grown by Molecular-Beam Epitaxy," O'Donnell et al., Appl. Physics Letters, vol. 76, no. 14, Apr. 2000, pp. 1914-1916.

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Mr. Bonick

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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

21	CN	"Integration of GaAs on Si using a spinel buffer layer, IBM Technical Bulletin," vol. 30, no. 6, Nov. 1987, p. 365
	CM	"GaInAs Superconducting FET," IBM Technical Bulletin, vol. 36, no. 8, Aug. 1993, p. 655.
	CO	"Epitaxial 3d Structure Using Mixed Spinel," IBM Technical Bulletin, vol. 30, no. 3, Aug. 1987, p. 1271.
	CP	"Roles of Buffer Layers in Epitaxial Growth of SrTiO ₃ Films on Silicon Substrates," Moon et al., Japan J of Appl Phys., vol. 33, 1994, pp 1472-1477.
	CQ	"GaAs Heteroepitaxial Growth on Si Substrates with Thin Si Interlayers in Situ Annealed at High Temperatures," Yodo et al., 8257b Journal of Vacuum Science & Technology, 1995, no. 3, pp. 1000-1005.
	CR	"Substrate Effect on the Superconductivity of Yba ₂ Cu ₃ O ₇ Thin Films," Cuomo et al., AIP conference 1988, pp. 141-148.
	CS	"Crystalline Oxides on Silicon: The First Five Monolayers," McKee et al., Physical Review Letters, vol. 81, no. 14, Oct. 1998, pp. 3014-3017.
	CT	"Molecular Beam Epitaxy Growth of Epitaxial Barium Silicide, Barium Oxide, and Barium Titanate on Silicon," McKee et al., 1991 American Institute of Physics, pp. 782-284.
	CU	"Molecular Beam Epitaxy Growth of SrTiO ₃ Films on Si(100)-2 x 1 with SrO Buffer Layer," Tambo et al., Jpn. J. Appl. Phys., vol 37, 1998 pp. 4454-4459.
	CV	"The MBE Growth and Optical Quality of BaTiO ₃ and SrTiO ₃ Thin Films on MgO," McKee et al., Mat. Res. Soc. Symp. Proc. Vol. 341, 1994, pp. 309-314.
	CW	"BaSi ₂ and Thin Film Alkaline Earth Silicides on Silicon," McKee et al., Appl. Phys. Lett. 63 (20), Nov. 1993, pp. 2818-2820.
	CX	"Surface Structures and the Orthorhombic Transformation of Thin Film BaSi ₂ on Silicon," McKee et al., Mat. Res. Soc. Symp. Proc. Vol. 221, pp. 131-136.
	CY	"Epitaxial Growth of SrTiO ₃ Films on Si(100) Substrates Using a Focused Electron Beam Evaporation Method," Mori et al. Jpn. J. of Appl. Phys., vol. 30, no. 8a, Aug. 1991, pp. 1415-1417.
	CZ	"Growth of Crystalline SrTiO ₃ Films on Si Substrates Using Thin Fluoride Buffer Layers and Their Electrical Properties," Moon et al., Jpn. J. of Apl. Phys., vol. 33, (1994), pp. 5911-5916.
21	DA	"The Epitactic Growth of Oxides on Si," S. Summerfelt, Materials Research Society Symposium Proceedings, vol. 221, 1991, pp. 29-34

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Jim Bowles

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